



PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: Ogata et al.

Examiner: Unassigned

Application No.: 10/589,382

Group Art Unit: Unassigned

Filed: August 15, 2006

Docket: 1608-6 PCT/US

For: **PHOTORESIST COMPOSITION AND  
METHOD OF FORMING RESIST PATTERN**

Dated: December 15, 2006

Confirmation No.: Unassigned

I hereby certify this correspondence is being deposited  
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Date: December 15, 2006

K.J. Goodhand/  
Name (Print)

K. J. Goodhand  
(Signature)

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**PRELIMINARY AMENDMENT**

Sir:

Please amend the above-identified application as follows:

**Amendments to the Specification** begin on page 2 of this submission.

**Remarks** begin on page 3 of this submission.